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I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450

Sara Carter

Type or print name

Signature

September 03, 2003

Date

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF

QIU ET AL.

APPLICATION NO:

FILED: SEPTEMBER 3, 2003

FOR: LBL- COATED MEDICAL DEVICE AND METHOD FOR MAKING

THE SAME

Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

This paper is being filed within three months of the filing date of the application.

Therefore, no fees are required. If a fee is deemed to be required, the Commissioner is hereby authorized to charge such fee to Deposit Account No. 19-0134.

In accordance with 37 C.F.R. §1.56, applicants wish to call the Examiner's attention to the references cited on the attached form(s) PTO-1449.

Copies of these references are enclosed herewith.

The Examiner is requested to consider the foregoing information in relation to this application and indicate that each reference was considered by returning a copy of the initialed PTO 1449 form(s).

Novartis Pharmaceuticals Corporation Patent and Trademark Dept. One Health Plaza East Hanover, NJ 07936-1080

(678) 415-4691

Date: September 03, 2003

Respectfully submitted,

Jian Zhou

Agent for Applicants Reg. No. 41,422 FORM PTO-1449 (REV. 7-85)

EXAMINER

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

ATTY. DOCKET NO. CL/V-32635A APPLICATION NO.

APPLICANT
QIU ET AL.
FILING DATE
SEPTEMBER 3, 2003

Group

U.S. PATENT DOCUMENTS EXAMINER INITIAL **DOCUMENT NUMBER** DATE NAME **CLASS SUBCLASS** FILING DATE AA 2001/0045676 11/29/01 Winterton et al. 264 2.5 1/31/01 AB 2001/0048975 12/6/01 Winterton et al. 427 412.1 2/1/01 AC 2002/0006493 1/17/02 Chabrecek et al. 428 64.1 5/30/01 AD 2002/0006493 1/17/02 Chabrecek et al. 428 64.1 5/30/01 ΑE 7/4/02 2002/0086160 Qiu et al. 428 413 8/24/01 AF 2003/0008154 1/9/03 Aguado et al. 428 447 5/22/02 AG 6,451,871 9/17/02 Winterton et al. 523 106 4/27/00 ΑН 2002/0182316 12/5/02 Gilliard et al. 427 162 5/22/02 ΑI 2003/0012872 1/16/03 Qiu et al. 427 162 5/22/02 AJ 2003/0039742 2/27/03 2.1 Qiu et al. 427 5/22/02 ΑK 2003/1117579 7/26/03 Morris et al. 351 200 11/4/02 AL 2003/0134132 7/17/03 Winterton et al. 428 451 1/8/03 FOREIGN PATENT DOCUMENTS TRANSLATION YES NO DOCUMENT NUMBER DATE **OFFICE CLASS SUBCLASS** AM EP 0 032 443 5/6/85 **EPO** ΑN EP 0 138 385 4/18/90 **EPO** AO GB 2 102 070 1/26/83 UK AP JP 1-158412 **JPO** AQ JP 5-318118 JPO OTHER DOCUMENTS (Including Author, Title, Date, Pertinent pages, Etc.) European Search Report AR Decher, Lehr, Lowack, Lvov & Schmitt, "New Nanocomposite Films for Biosensors: layer by Layer AS adsorbed films of polyelectrolytes, proteins or DNA", 1994, pp677-684 Sukhorukov, Mohwald, Decher and Lvov, "Assembly of Polyelectrolyte Multilaver films by consecutively alternating adsorption of Polynucleotides and Polycations", 1996, pp. 220-223 AT

DATE CONSIDERED

^{*}EXAMINER: Initial of reference considered, whether or not citation is in conformance with MPEP 609: Draw a line through citation if not in conformance and not considered. Include a copy of this form with the next communication to applicant.

FORM PTO-1449 (REV. 7-85) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

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APPLICANT
QIU ET AL.
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SEPTEMBER 3, 2003

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	DA	Uchida, Kunitake, and Kajiyama, "Blood Compatibility - Surface Characteristic Relationships of a Langmuir-Blodgett Film COmposed of an Anionic Amphiphile-Polycation COmplex", 1994, pp. 199-211
	DB	Onitsuka, Fou, Ferreira, Hsieh, and Rubner, "Enhancement of Light Emitting Diodes Based on Self-Assembled Heterostructures of Poly(p-PHenylene Vinylene)", 1996, pp.4067-4071
	DC	Yoo, Lee and Rybner, "Investigations of New Self-Assembled MultiLayer Thin Films Based on Alternately Adsorbed Layers of Polyelectrolytes and Functional Dye Molecules", 1996, pp.395-400
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	DK	
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FORM PTO-1449 (REV. 7-85) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE CITATION

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SEPTEMBER 3, 2003

Group

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			FOREIG	N PATENT DOCUMENTS	· · · · · · · · · · · · · · · · · · ·	<u> </u>	!		
		DOCUMENT NUMBER	DATE	OFFICE	CLASS	SUBCLASS	TRAN YES	TRANSLATION YES NO	
	ВМ	WO 95/00618	1/5/95	PCT					
	BN	WO 95/02251	1/19/95	PCT					
	во	WO 95/20407	8/3/95	PCT					
	BP	WO 96/18498	6/20/96	PCT					
	BQ	WO 96/31792	10/10/96	PCT					
		OTHER DOC	UMENTS (Including Author, Title, Date, Pertind	ent pages, E	tc.)		<u> </u>	
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EXAMINE	R			DATE CONSIDERED					

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Sheet 4 of 4

FORM PTO-1449 (REV. 7-85) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

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FILING DATE
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FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER WO 96/37241	11/28/96	OFFICE	CLASS	SUBCLASS	TRANSLATION YES NO	
	CA							
	СВ							
	СС							
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